



STIC Search Report

EIC 2800

STIC Database Tracking Number:

TO: David Hogans
Location: CP4-4D14
Art Unit: 2813
8/22/2003

Case Serial Number: 09/763365

From: Jeff Harrison
Location: STIC-EIC2800
CP4-9C18
Phone: 306-5429

Email: harrison, jeff

Search Notes

Examiner Hogans,

Re: Doping Ge layer with a p-type impurity;
Ge layer must be on gate insulation film

Attached are search results from the patent and NPL literature.

I did not find all the specifics together.

Based on this, if you have questions or would like a refocused search, please contact me.

Thanks,
Jeff

Jeff Harrison
Team Leader, STIC-EIC2800
CP4-9C18, 703-306-5429





STIC Search Results Feedback Form

EIC 2800

Questions about the scope or the results of the search? Contact **the EIC searcher or contact:**

Jeff Harrison, EIC 2800 Team Leader
306-5429, CP4-9C18

Voluntary Results Feedback Form

➤ I am an examiner in Workgroup: Example: 2810

➤ Relevant prior art found, search results used as follows:

- 102 rejection
- 103 rejection
- Cited as being of interest.
- Helped examiner better understand the invention.
- Helped examiner better understand the state of the art in their technology.

Types of relevant prior art found:

- Foreign Patent(s)
- Non-Patent Literature
(journal articles, conference proceedings, new product announcements etc.)

➤ Relevant prior art not found:

- Results verified the lack of relevant prior art (helped determine patentability).
- Results were not useful in determining patentability or understanding the invention.

Comments: